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Bib Data Sheet

CONFIRMATION NO. 2239

<b>SERIAL NUMBER</b> 09/759,639	<b>FILING DATE</b> 01/16/2001 <b>RULE</b>	<b>CLASS</b> 257	<b>GROUP ART UNIT</b> 2818	<b>ATTORNEY DOCKET NO.</b> OKI.206	
<b>APPLICANTS</b> Masahiro Yoshida, Tokyo, JAPAN; Shunichi Tokitoh, Tokyo, JAPAN;  <b>** CONTINUING DATA *****</b> <i>None, TH</i> <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2000-010250 01/17/2000 <i>Yes, TH</i> <b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 02/28/2001</b>					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>Allowance</i> Examiner's Signature <i>TH</i> Initials		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 23	<b>TOTAL CLAIMS</b> 18	<b>INDEPENDENT CLAIMS</b> 7
<b>ADDRESS</b> JONES VOLENTINE, LLC SUITE 150 12200 SUNRISE VALLEY DRIVE RESTON, VA 20191					
<b>TITLE</b> Semiconductor device having a thick oxide layer under gate side walls and method for manufacturing the same					
<b>FILING FEE RECEIVED</b> 1160	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees		
			<input type="checkbox"/> 1.16 Fees ( Filing )		
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